



Attorney's Docket No.: 12732-171001 / US6695

DSO
GA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Masaharu Nagai et al. Art Unit : 1756
Serial No. : 10/694,986 Examiner : Daborah Chacko Davis
Filed : October 29, 2003
Title : METHOD FOR REMOVING RESIST PATTERN AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL LETTER

Correspondence relating to this application is enclosed. The required fees are computed below. Please apply any charges not covered, or any credits, to Deposit Account No. 06-1050.

Total Claims	19	-	20	=	0	\$0
Independent	6	-	6	=	0	\$0
First Presentation of Multiple Dependent Claims						\$0

Applicant hereby petitions under 37 C.F.R. §1.136 for a 2 month extension of time.

\$450

TOTAL FEE DUE

\$450

A check in the amount of \$450 is enclosed.

Respectfully submitted,

Date: March 3, 2006

/Diana DiBerardino/
Diana DiBerardino
Reg. No. 45,653

Fish & Richardson P.C.
1425 K Street, N.W.
11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331

40318376.doc

03/06/2006 SZEWDIE1 00000012 10694986

01 FC:1252

450.00 0P